

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang

Art Unit : 2814

Serial No. : 09/362,808

Examiner : Shrinivas H. Rao

Filed : July 28, 1999

Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF OCTOBER 17, 2005

Please amend the above-identified application as follows:

The currently pending are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 13 of this paper.

Remarks/Arguments begin on page 14 of this paper.

An **Appendix** including amended drawing figures is attached following page 16 of this paper.